



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

December 26, 2025

IGI Report Number **LG760543264**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.01 X 7.25 X 4.49 MM**

#### GRADING RESULTS

Carat Weight **2.05 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

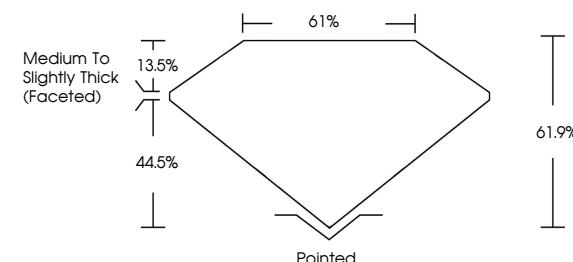
Symmetry **EXCELLENT**

Fluorescence **NONE**

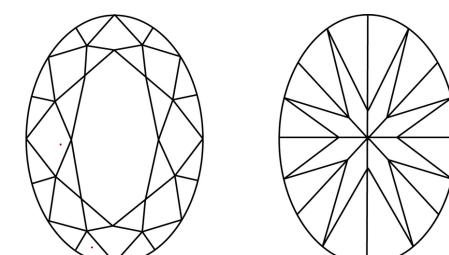
Inscription(s) **IGI LG760543264**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](http://www.igi.org)

LG760543264  
Report verification at [igi.org](http://igi.org)

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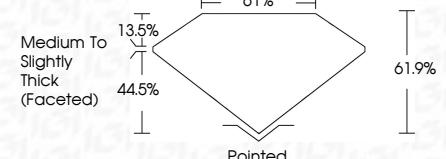
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Sample Image Used



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December 26, 2025	IGI Report No LG760543264	OVAL BRILLIANT	2.05 CARATS	D	VS 1	61.9%	61.5%	Medium to Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG760543264
				Carat Weight	Color Grade	Clarity Grade	Depth	Table Grade		Culet	Symmetry	Fluorescence	Inscription(s)
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